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## \*\* CONTINUING DATA \*\*\*\*\*

None SJL

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2002-240082 08/21/2002 SJL

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 16	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 5
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>[Signature]</i> Examiner's Signature				

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## TITLE

Resist pattern thickening material, process for forming resist pattern, and process for manufacturing semiconductor device

FILING FEE

FEES: Authority has been given in Paper

☐ All Fees☐ 1.16 Fees ( Filing )☐ 1.17 Fees ( Processing Ext. of